OK TO ENTER: /E.D./

## **SIEMENS**

In re Application of:

PATENT Attorney Docket No. 2003P14790WOUS

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:	S. Haaks et al.	)	Group Art Unit: 2857	
Serial No.:	10/573,674	)	Examiner:	Desta, Elias
Filed:	10/25/2006	)	Confirmation No. 5072	
Title:	METHOD AND DEVICE FOR DETERMINING THE CAUSES OF MALFUNCTIONS AND PERFORMANCE LIMITS IN INSTALLATIONS			
/E.D./				

Mail Stop AF **Commissioner For Patents** P.O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE UNDER 37 CFR 1.116

Sir:

OK TO ENTER:

In response to the Final Office Action mailed December 11, 2007 Applicants respectfully request reconsideration in view of the following remarks provided in connection with the above-identified application.

(please proceed to page 2)